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**FACSIMILE COVER SHEET**

To: United States Patent & Trademark Office  
Group Art Unit 2133

Re: **Request for Corrected  
Filing Receipt**

Pages including coversheet: 3

FAX No.: (703) 746-9195

**CERTIFICATE OF FACSIMILE**

I hereby certify that this correspondence and the papers referred to herein as attached are being transmitted to the United States Patent and Trademark Office via facsimile to (703) 746-9195, Attn: Office of Initial Patent Examination's Filing Corrections, P.O. Box 1450, Alexandria, VA 22313-1450, on November 19, 2004.

Signed: \_\_\_\_\_

Cynthia Dawn

Application No. : 10/789,524  
Applicant: : Miguel Angel Saldana  
Filed: : February 26, 2004  
Title: : APPARATUS WITH RESOLUTION  
ENHANCEMENT FEATURE FOR IMPROVING ACCURACY OF CONVERSION OF  
REQUIRED CHEMICAL MECHANICAL POLISHING PRESSURE TO FORCE TO BE  
APPLIED BY POLISHING HEAD TO WAFER

Atty. Docket No. : SUNMP255D2  
Date : November 19, 2004

*Attached to this facsimile coversheet are the following documents:*

- Request for Corrected Filing Receipt (1 page)
- Copy of Filing Receipt having highlighted corrections (1 page)

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**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the application of )

Miguel Angel Saldana )

Application No. 10/789,524 )

Filed: February 26, 2004 )

For: APPARATUS WITH RESOLUTION  
ENHANCEMENT FEATURE FOR IMPROVING  
ACCURACY OF CONVERSION OF REQUIRED  
CHEMICAL MECHANICAL POLISHING  
PRESSURE TO FORCE TO BE APPLIED BY  
POLISHING HEAD TO WAFER )

Examiner: Not Assigned

Art Unit: 2133

Docket No. SUNMP255D2

Date: November 19, 2004

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Signed: Cynthia Dawn

Cynthia Dawn

**REQUEST FOR CORRECTED FILING RECEIPT**

Commissioner for Patents  
Office of Initial Patent Examination's Filing Corrections  
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Alexandria, VA 22313-1450

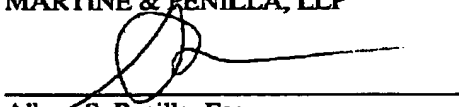
Sir:

Enclosed is a copy of the Filing Receipt for the above-identified patent application. Please reprint the Filing Receipt as follows and mail the corrected copy to the undersigned.

In the Drawings, change the number from "3" to -- 16 --. Thus, as corrected, the number of drawings of the subject patent application is "16".

Applicants submit that no fee is due because the U.S. Patent and Trademark Office caused the error for which correction is requested. Nevertheless, in the event it is determined that any fees are due, such fees may be charged to Deposit Account 50-0805 (Order No. SUNMP255D2).

Respectfully submitted,  
MARTINE & PENILLA, LLP

  
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## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/789,524	02/26/2004	2133	770	LAM2P255D2	16	11	3

CONFIRMATION NO. 9272

25920.  
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## FILING RECEIPT



\*OC000000012711183\*

Date Mailed: 05/19/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Miguel Angel Saldana, Fremont, CA;

## Assignment For Published Patent Application

LAM Research Corporation;

## Domestic Priority data as claimed by applicant

This application is a DIV of 09/823,151 03/29/2001 PAT 6,725,120

## Foreign Applications

If Required, Foreign Filing License Granted: 05/19/2004

Projected Publication Date: 08/26/2004

Non-Publication Request: No

Early Publication Request: No

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## Title

Apparatus with resolution enhancement feature for improving accuracy of conversion of required chemical mechanical polishing pressure to force to be applied by polishing head to wafer